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**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2800**

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*42700*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masuyuki KIKUSHIMA et al.

Group Art Unit: 2834

Application No.: 09/120,806

Examiner: M. Budd

Filed: July 23, 1998

Docket No.: 101151

For: PIEZO-ELECTRIC RESONATOR AND MANUFACTURING METHOD THEREOF

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated January 14, 2000, please amend the above-identified application as follows:

**IN THE CLAIMS:**

Please amend claim 8 as follows:

8. (Amended) A piezo-electric resonator comprising:
- a housing having an opening; and
  - a piezo-electric resonator element provided in the housing, said housing comprising a first ceramic substrate having a first thickness, and a second ceramic substrate provided with the opening and having a second thickness larger than the first thickness, the second ceramic substrate being laminated on the first ceramic substrate, and an edge portion of the opening and a periphery of the opening being metallized.

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